



**ELECTRONIC COPY**

LG665410892  
Report verification at igi.org



November 14, 2024

IGI Report Number **LG665410892**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **13.01 X 7.01 X 4.44 MM**

**GRADING RESULTS**

Carat Weight **2.33 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

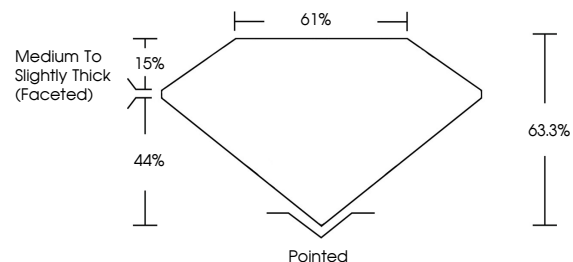
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG665410892**

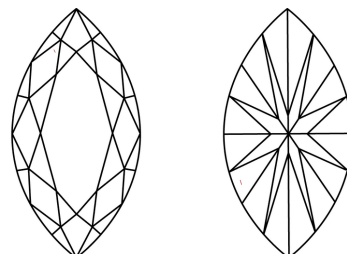
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

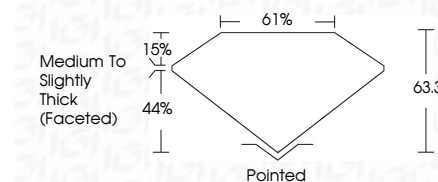
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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MARQUISE BRILLIANT

13.01 X 7.01 X 4.44 MM

2.33 CARATS  
F

Carat Weight  
Color Grade  
Clarity Grade  
Table  
Depth  
Girdle  
Medium to Slightly Thick (Faceted)

63.3%  
61%

Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG665410892

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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